

In-Situ Radiation Damage Studies for SCT Optical Links



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on behalf of the ATLAS SCT Collaboration

Radiation damage workshop

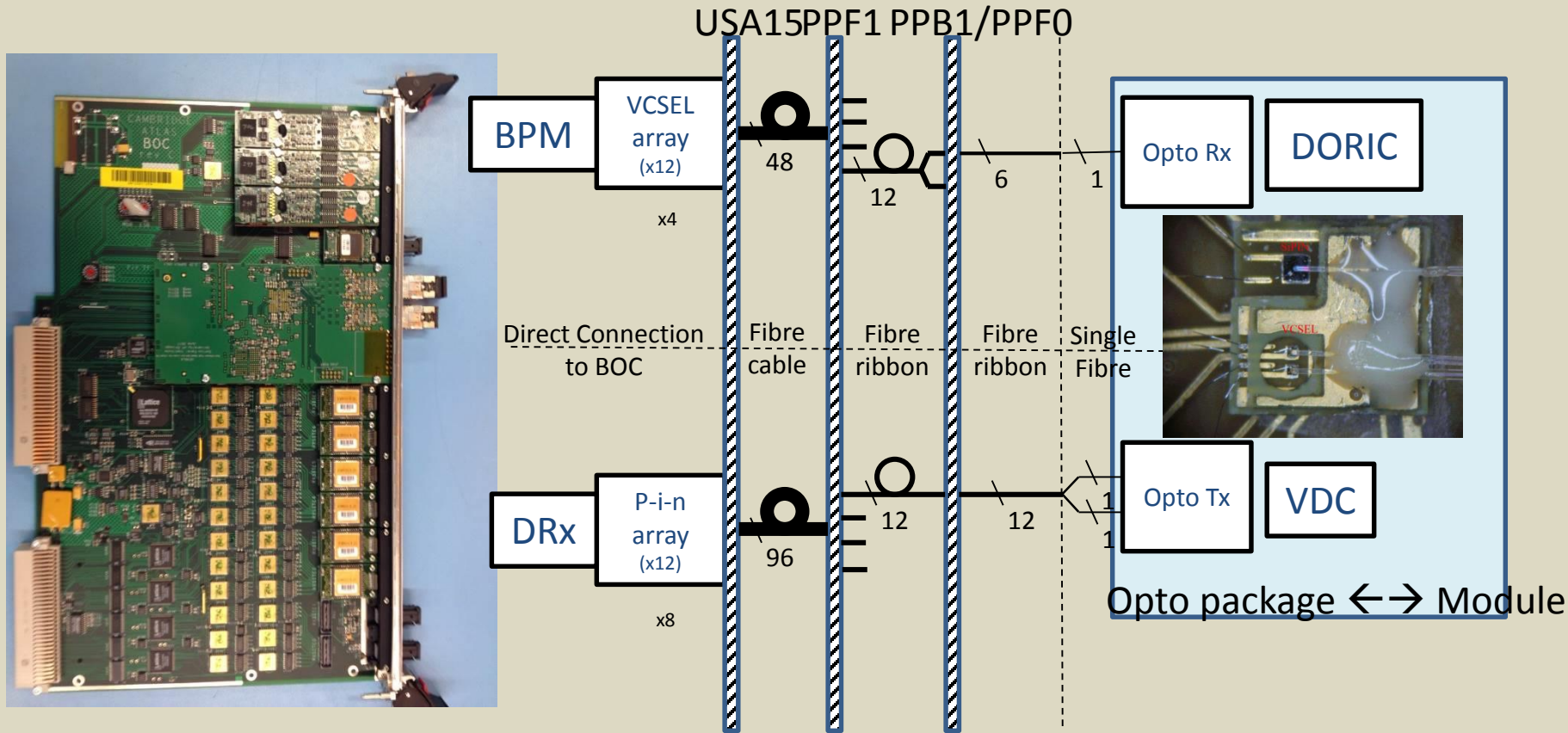
CERN, 23rd April



Outline

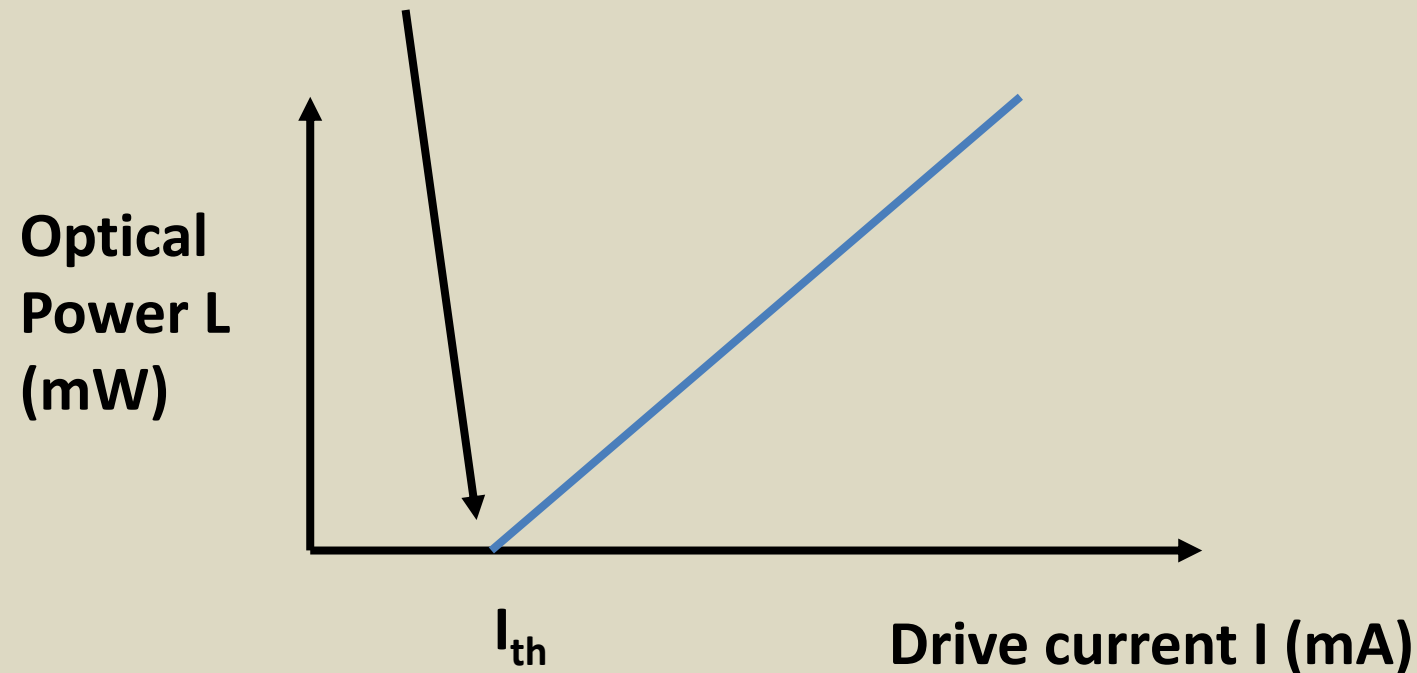
- **SCT optical links**
- **Summary test beam radiation damage**
 - VCSELs
 - *p-i-n* diodes
- **In-situ radiation damage studies**
 - VCSELs
 - *p-i-n* diodes
- **Comparisons test beam and in-situ measurements.**

SCT Optical Links



VCSEL Definitions

- Threshold and slope efficiency = dL/dI



Test Beam Studies: VCSELs

- **Beams used**
 - 30 MeV p, 24 GeV p and neutrons.
- **20 VCSELs from SCT production wafer.**
 - 30 MeV p, $F=2 \cdot 10^{14}$ p/cm².
 - Before irradiation: threshold (3.28 ± 0.09) mA.

Condition	Threshold shift (mA)	Relative slope efficiency (%)
After irradiation	3.0 ± 0.4	73 ± 4
+1 week annealing 10 mA	0.94 ± 0.11	88 ± 4
+1 week annealing 20 mA	0.42 ± 0.11	98 ± 3

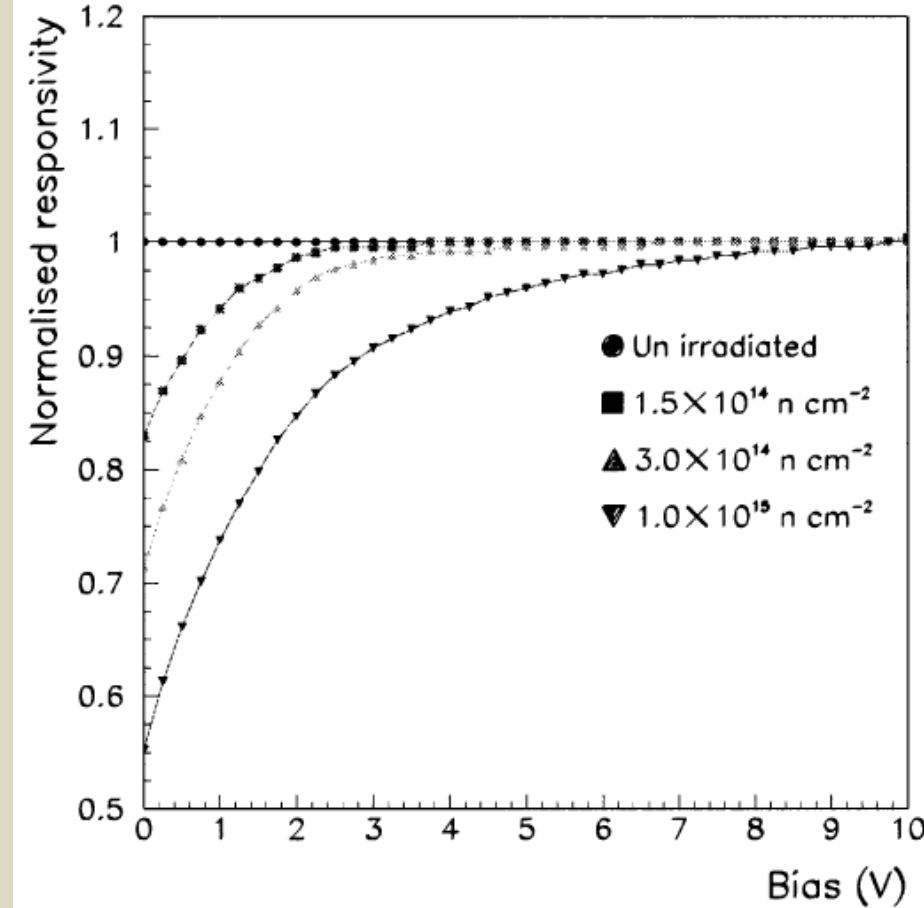
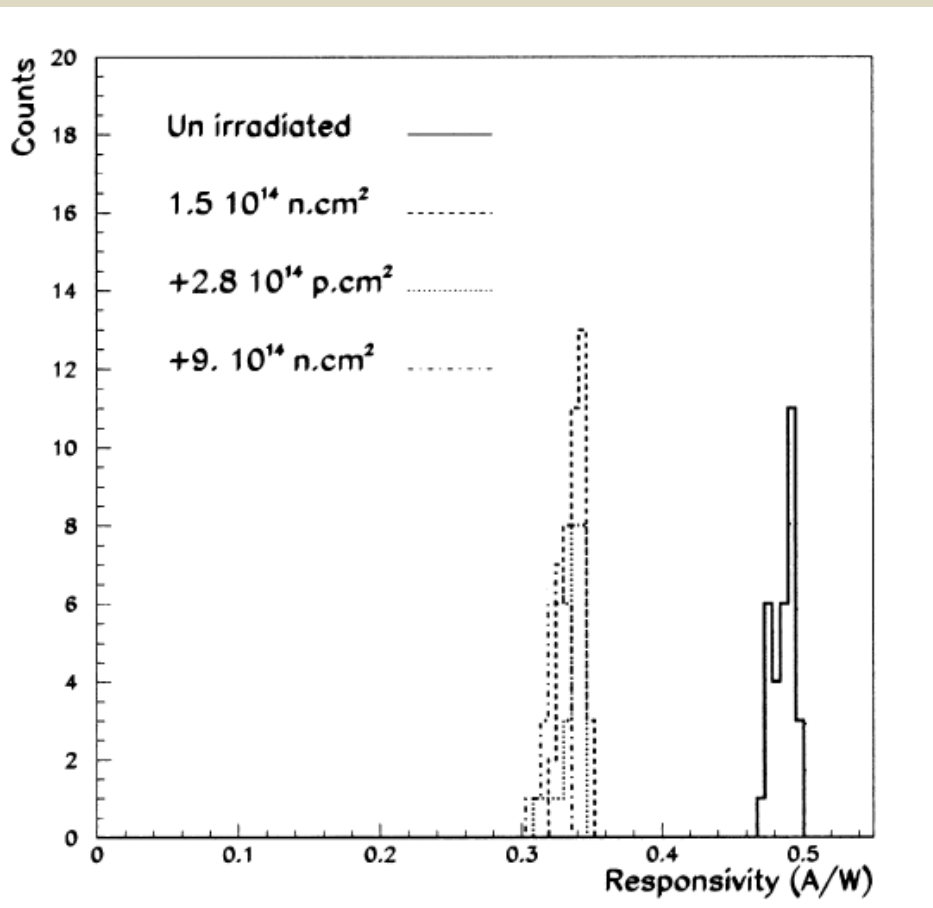
Test Beam Studies: p-i-n diodes



- **Samples**
 - 30 *p-i-n* diodes from ATLAS production wafer.
- **Beams used**
 - 24 GeV p and ISIS neutrons.
- **Measured dark current, responsivity and depletion voltage.**
 - Cumulative. $F = 1.05 \cdot 10^{15}$ (1 MeV n_{eq}/cm^2).
 - Decrease in responsivity
 - Increase in depletion voltage
 - (Increase in leakage current)

Responsivity

Depletion Voltage





Fluences

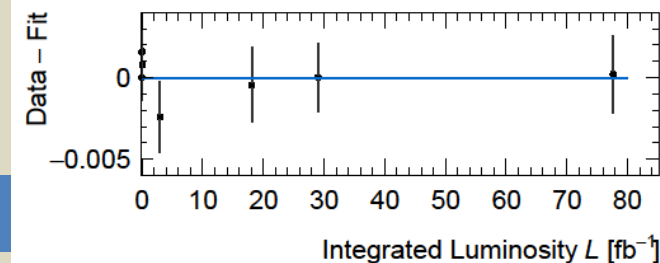
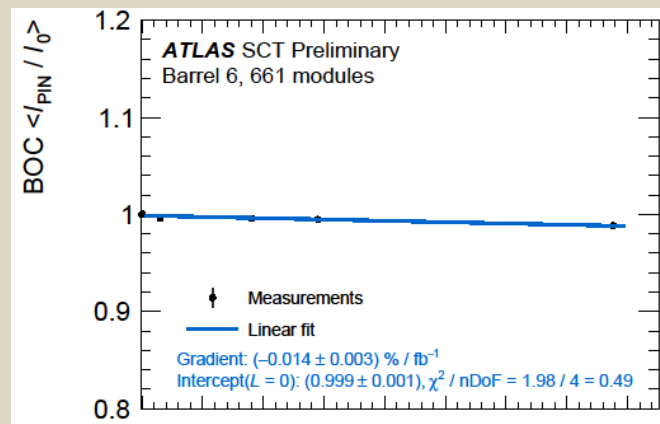
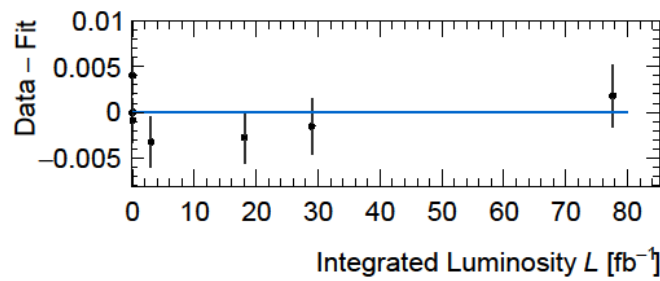
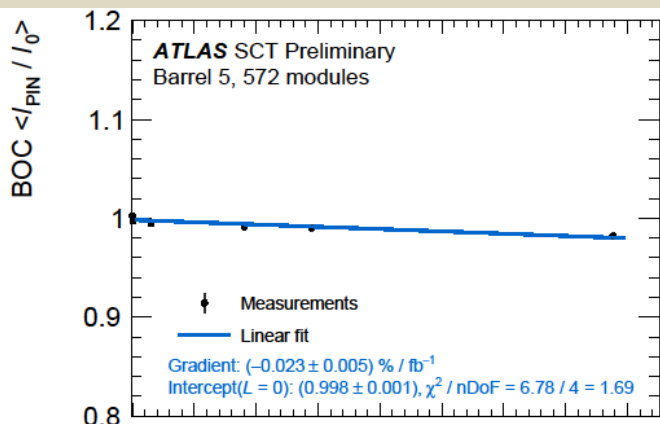
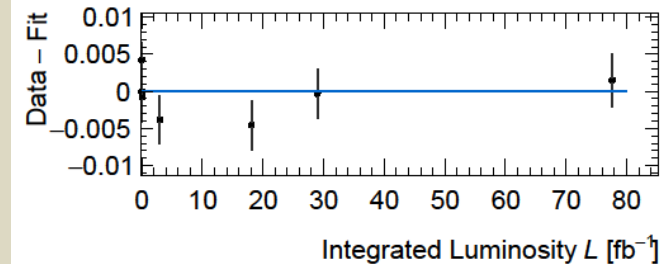
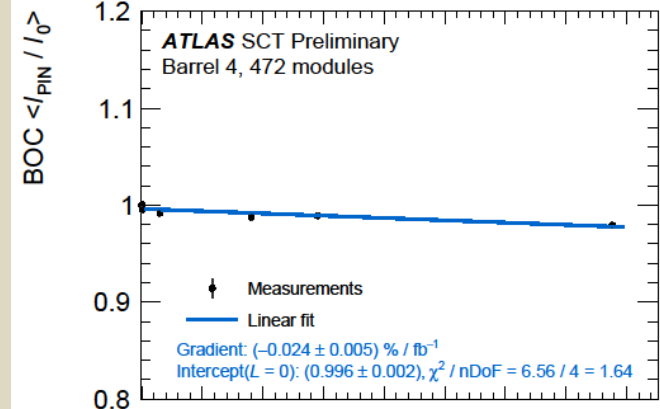
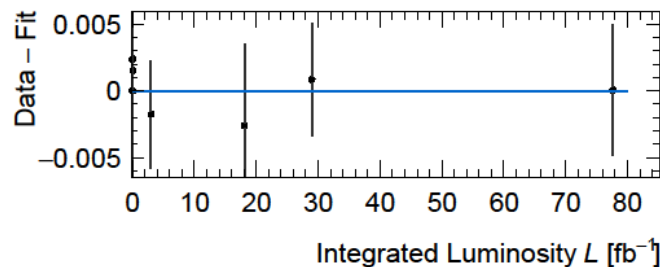
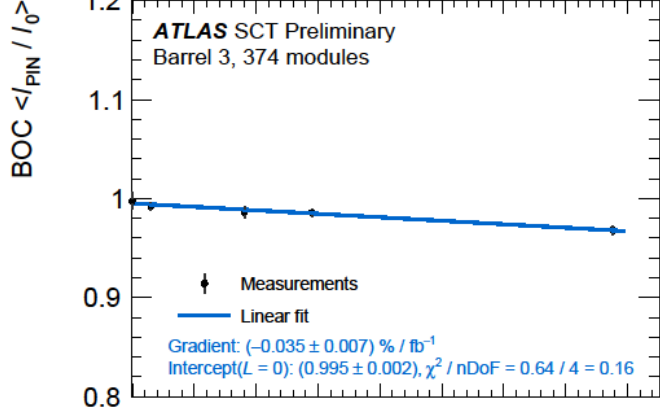
- Fluences calculated with Pythia8 and Fluka.
- Systematic error 30% (50%) barrel (End-cap).

Layer	Fluence (10^{11} (1 MeV n_{eq}) cm^{-2} fb^{-1})
Barrel 3	2.67
Barrel 4	2.12
Barrel 5	1.77
Barrel 6	1.53
End-cap inner	3.22
End-cap middle	2.66
End-cap outer	2.26

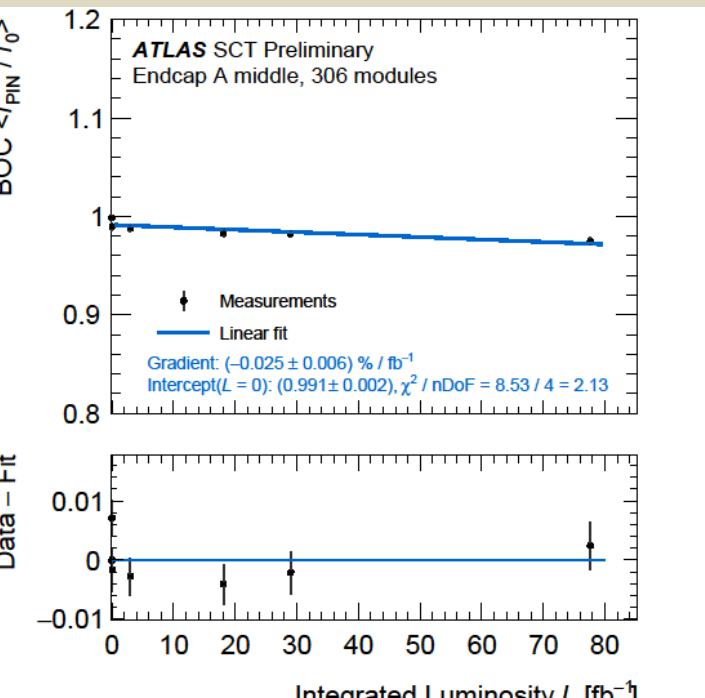
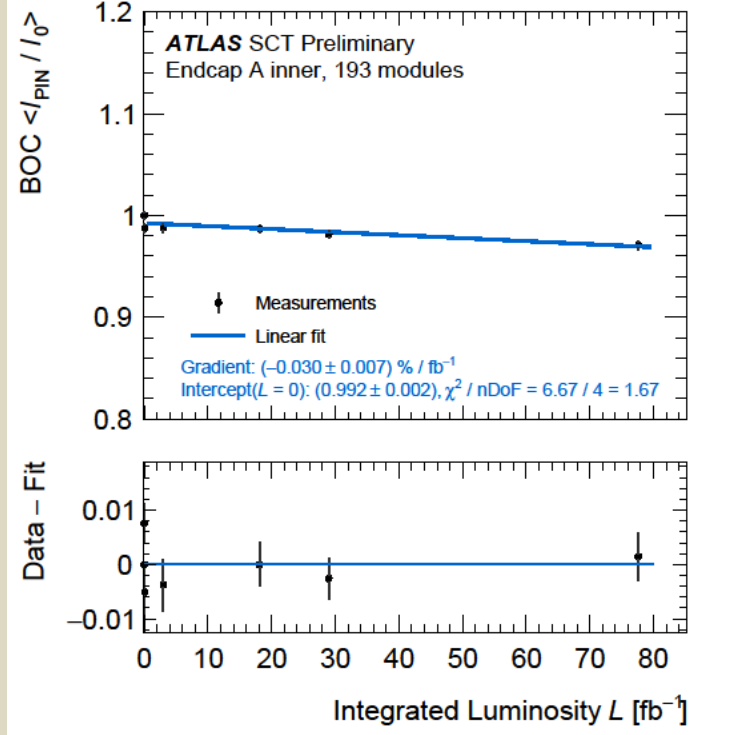
In-Situ Measurements: VCSELS



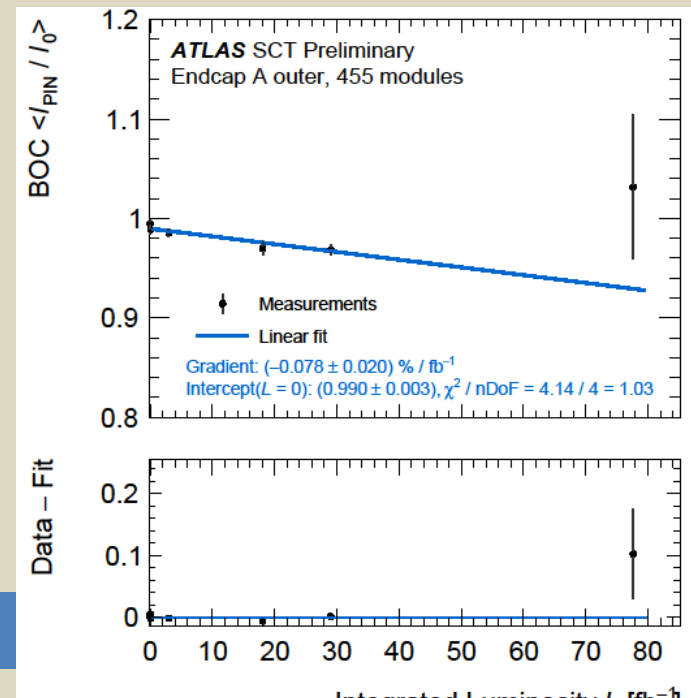
- Optical power measured in special scans by measuring photo-currents (I_{pin}) in receiver.
- For each barrel layer, EC ring, normalise photo-currents to start of 2016 data taking.
- For each scan, in each region determine $\langle I_{pin}/I_{pin_0} \rangle$
- Plot $\langle I_{pin}/I_{pin_0} \rangle$ vs luminosity.

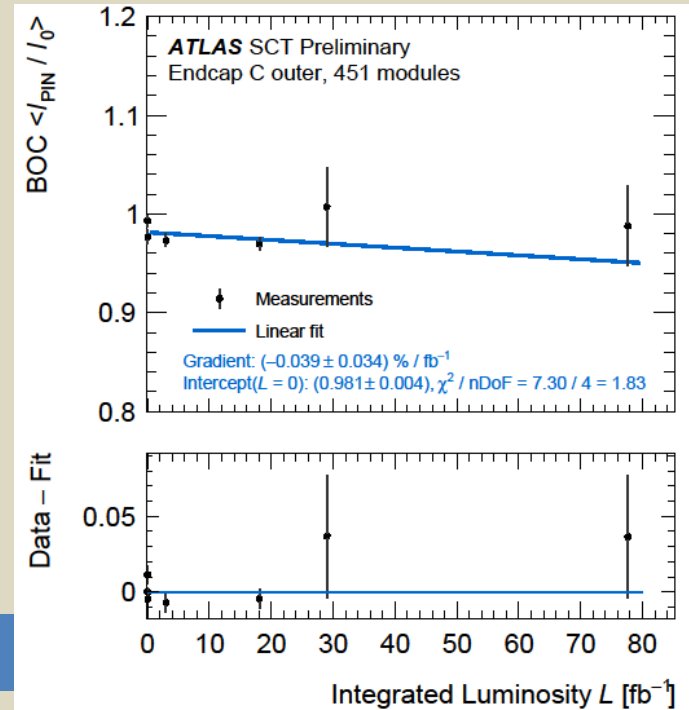
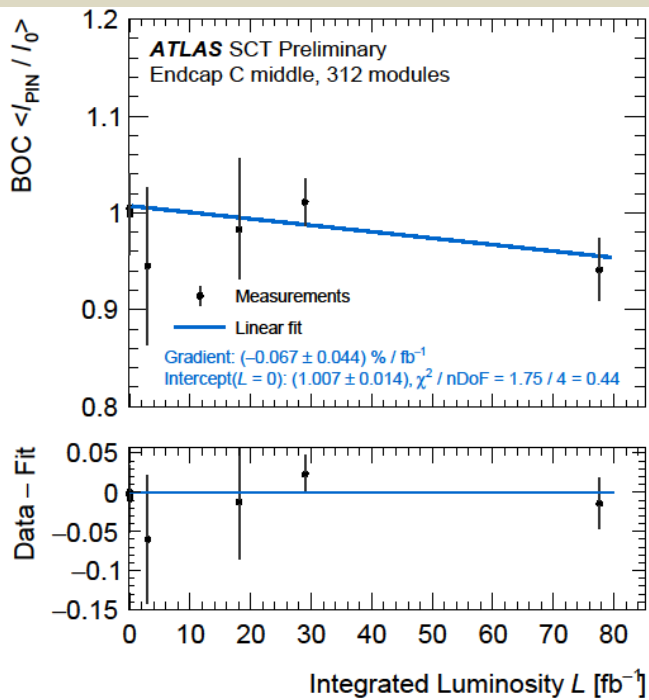
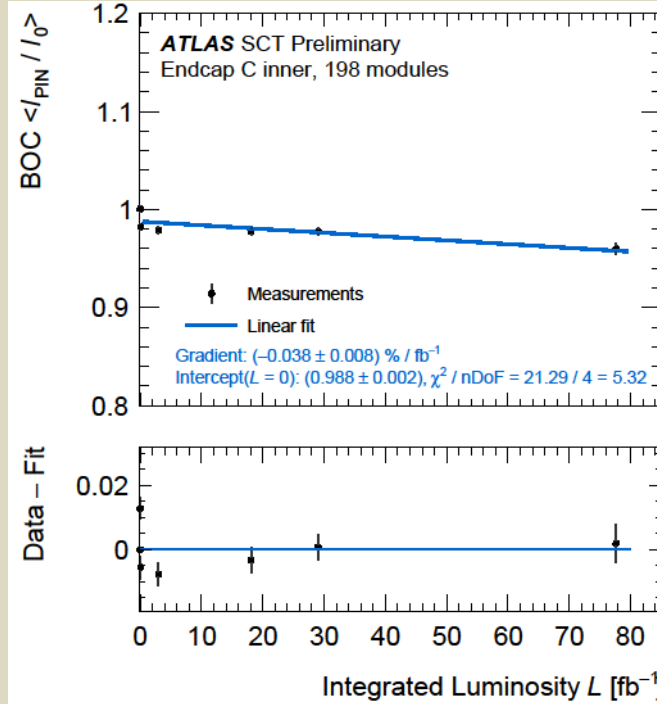


SCT Optical Links



SCT Optical Links





SCT Optical Links

VCSELs: Gradients



Gradient (%/fb)					
Barrel		EC-A		EC-C	
3	-0.035 ± 0.007	Inner	-0.03 ± 0.007	Inner	-0.038 ± 0.008
4	-0.024 ± 0.005	Middle	-0.025 ± 0.006	Middle	-0.067 ± 0.044
5	-0.023 ± 0.005	Outer	-0.078 ± 0.02	Outer	-0.039 ± 0.034
6	-0.014 ± 0.003				

- Consistent results. Normalise to expected fluences.
- Gradient = $(-1.09 \pm 0.09) \%/10^{11} (1 \text{ MeV } n_{\text{eq}}/\text{cm}^2)$

Comparison with Test Beam



- Assume
 - Change in threshold and slope efficiency scale with fluence
 - NIEL scaling for GaAs

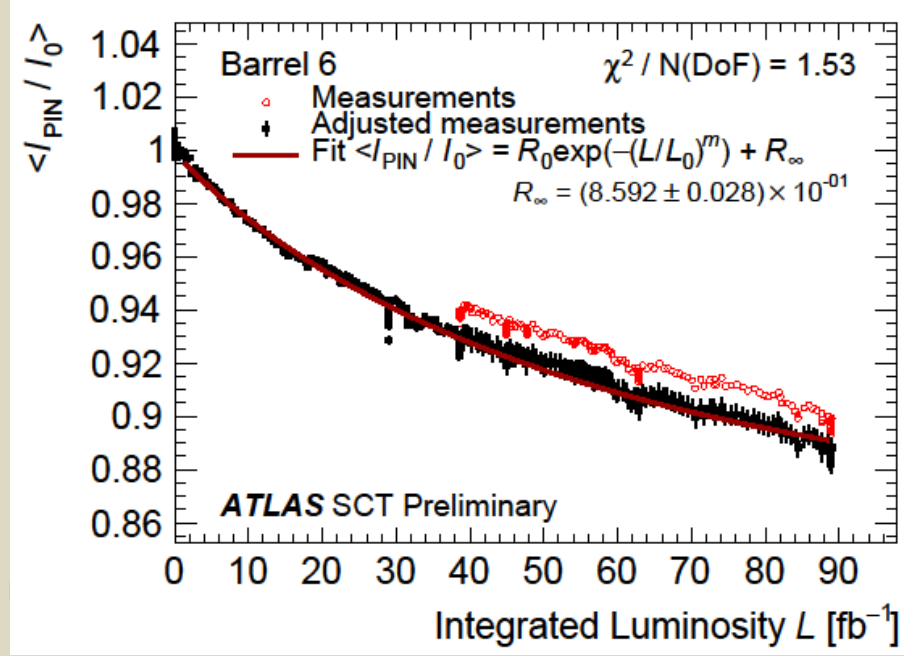
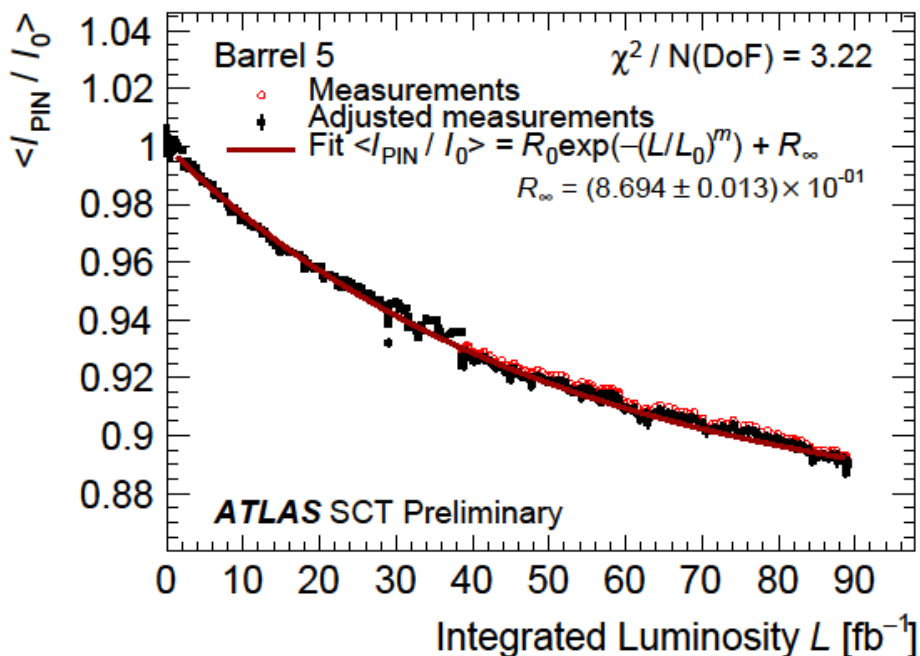
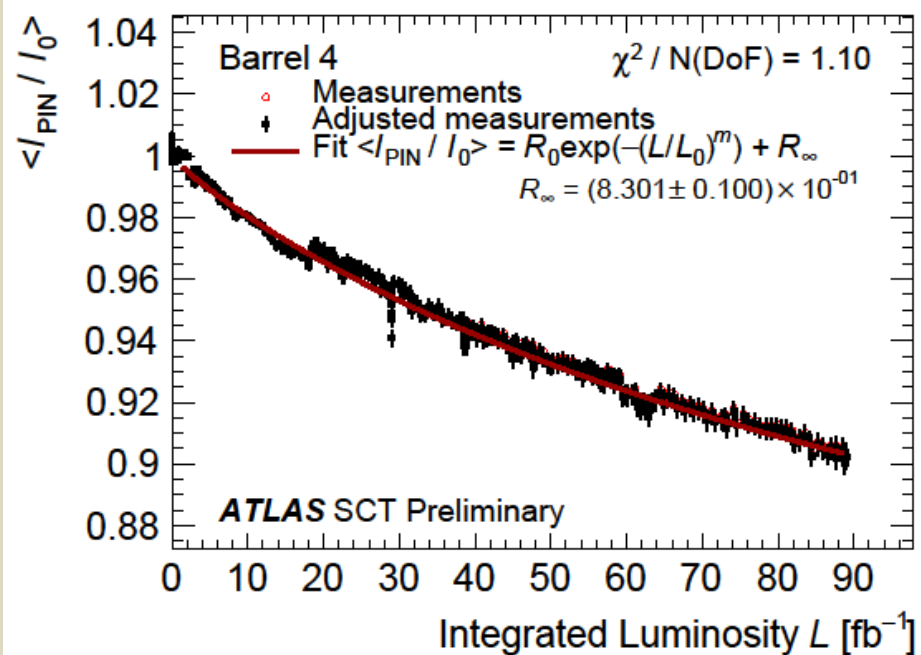
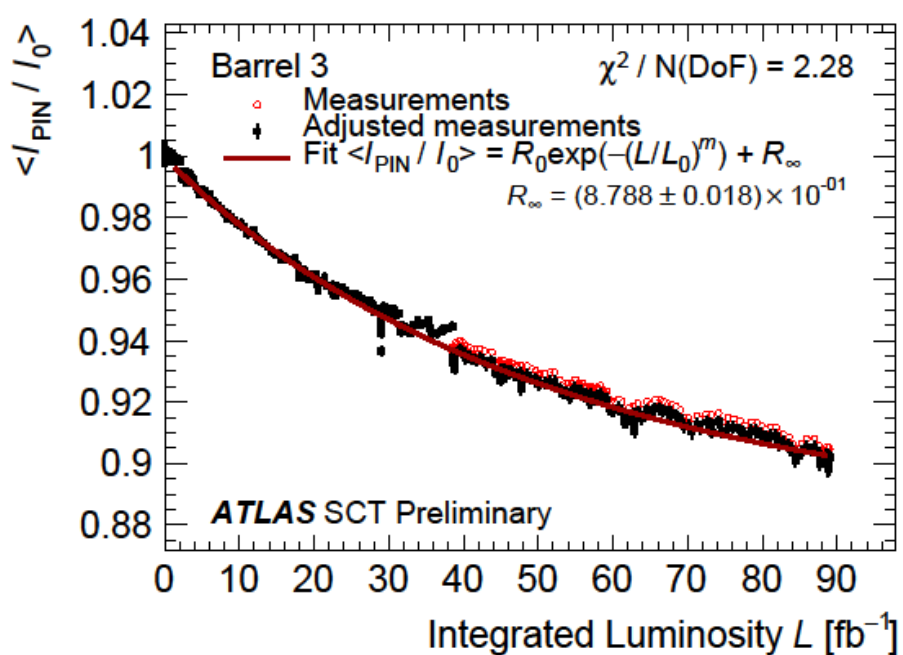
Condition	%/10 ¹¹ (1 MeV n _{eq} /cm ²)
In-situ	1.09 ± 0.09
Test beam no annealing	1.7
+ 1 week annealing 10 mA	0.6

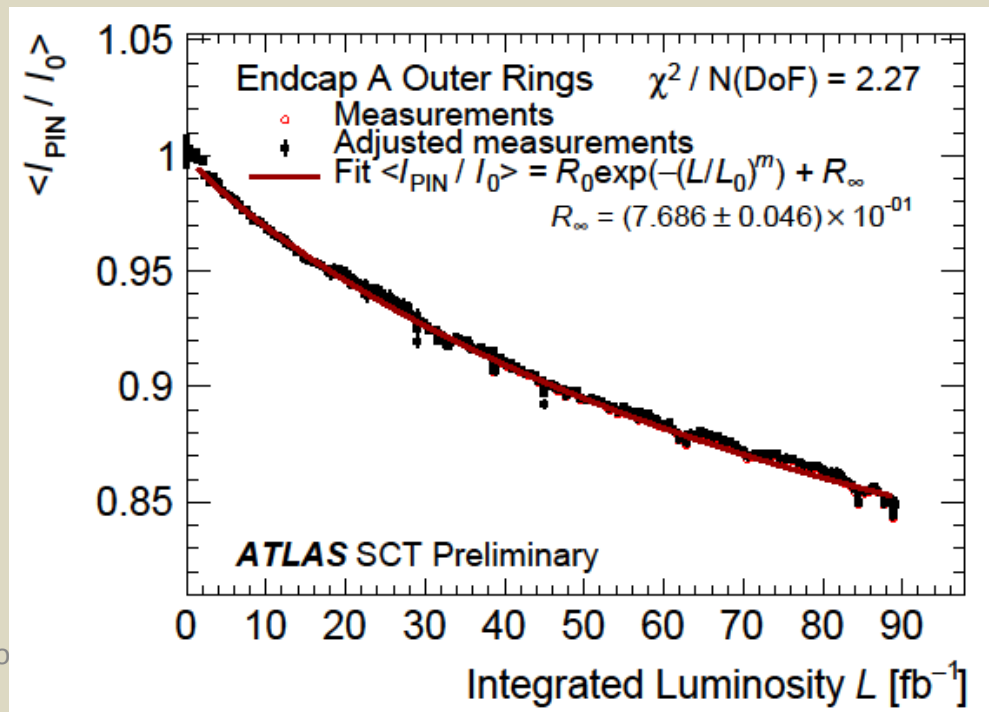
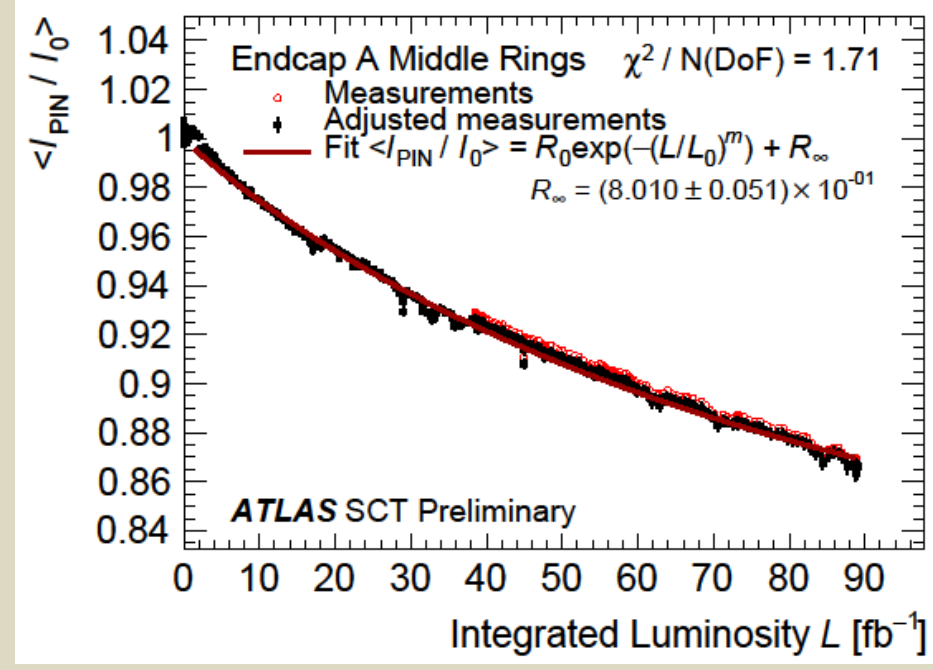
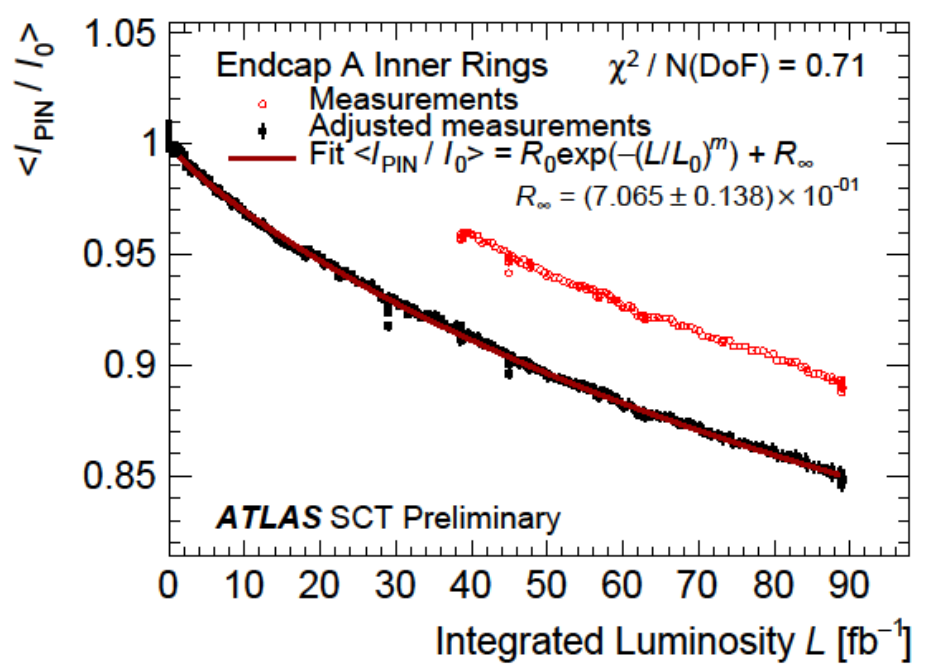
- 2016 operation equivalent to 6 weeks @ 10 mA DC.
- In-situ damage slightly larger than prediction?

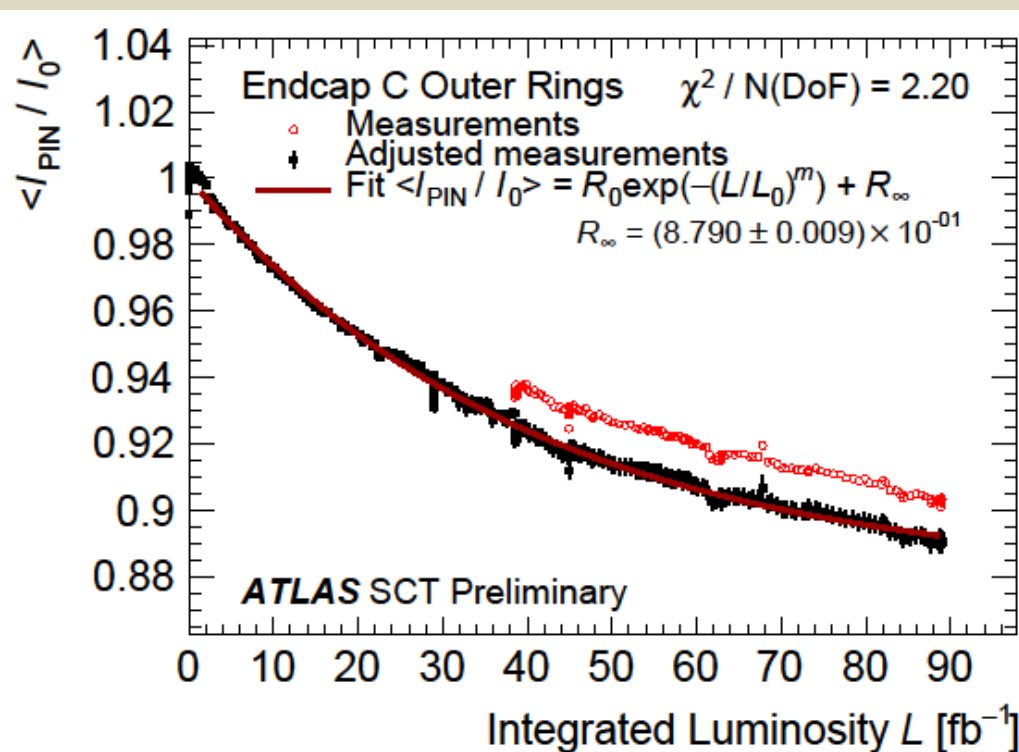
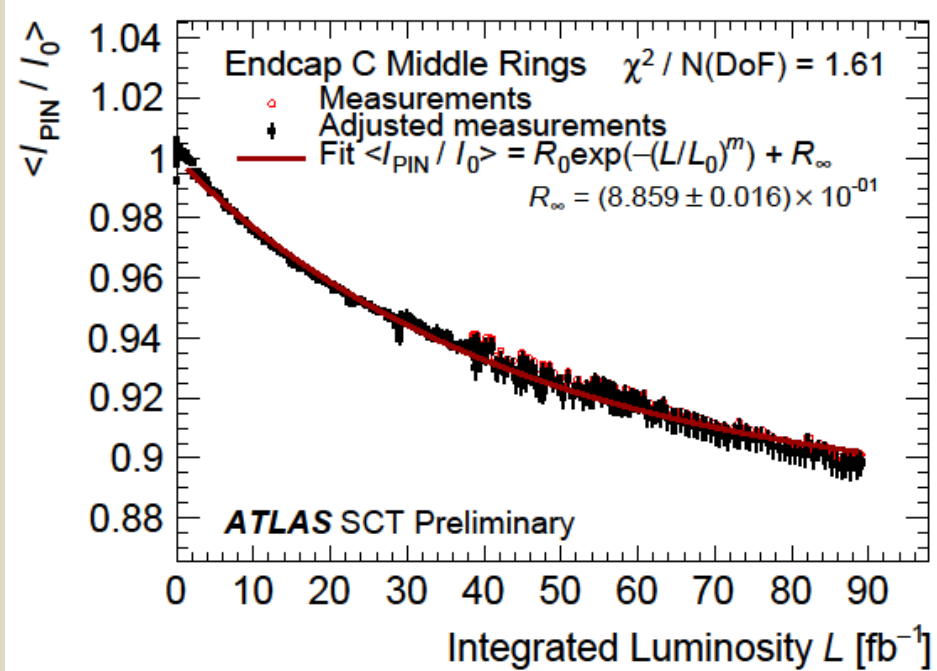
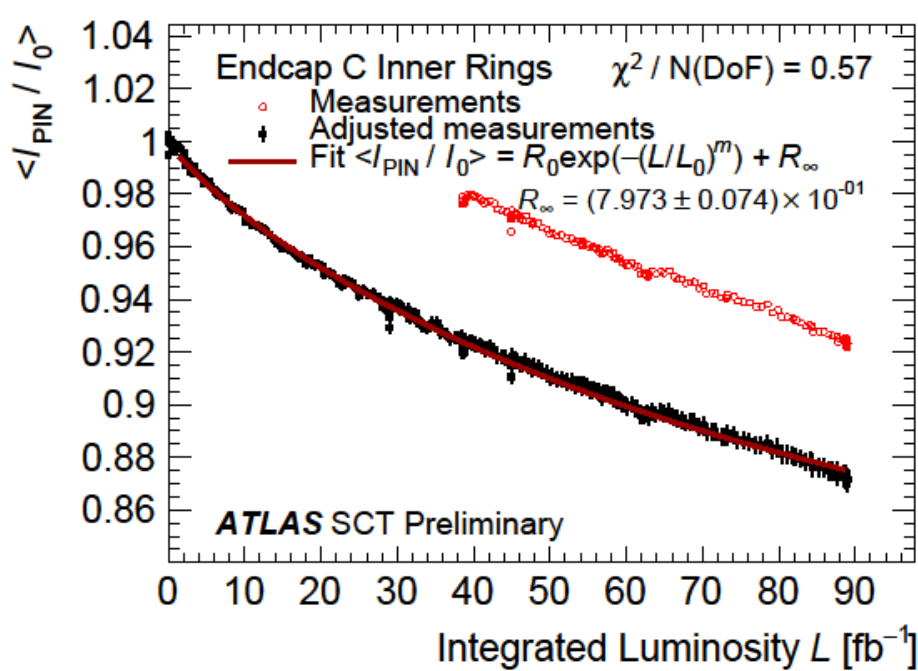


In-Situ Measurements: *p-i-n* diodes

- Optical power measured every minute by power supplies.
- Average over 24 hours.
- For each barrel layer, EC ring, normalise photocurrents to start of 2016 data taking.
 - In some cases re-normalise 2017 data.
- For each scan, in each region determine $\langle I_{pin}/I_{pin_0} \rangle$
- Plot $\langle I_{pin}/I_{pin_0} \rangle$ vs luminosity.



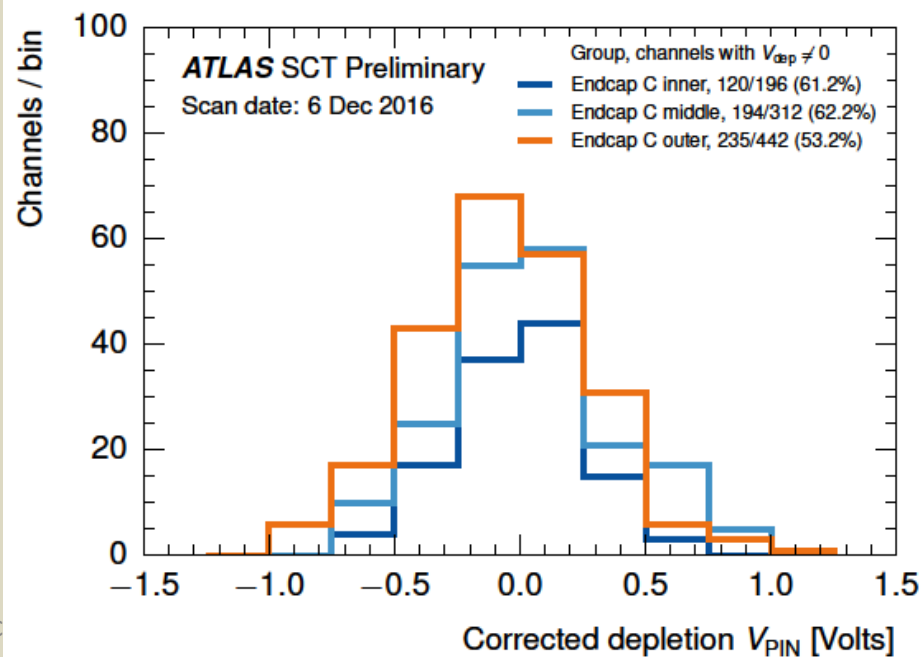
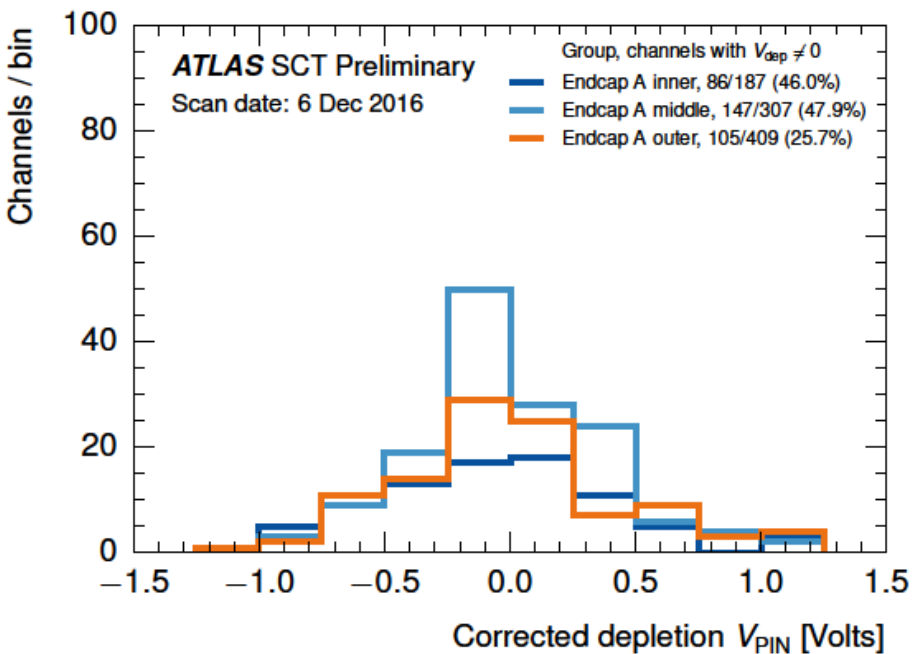
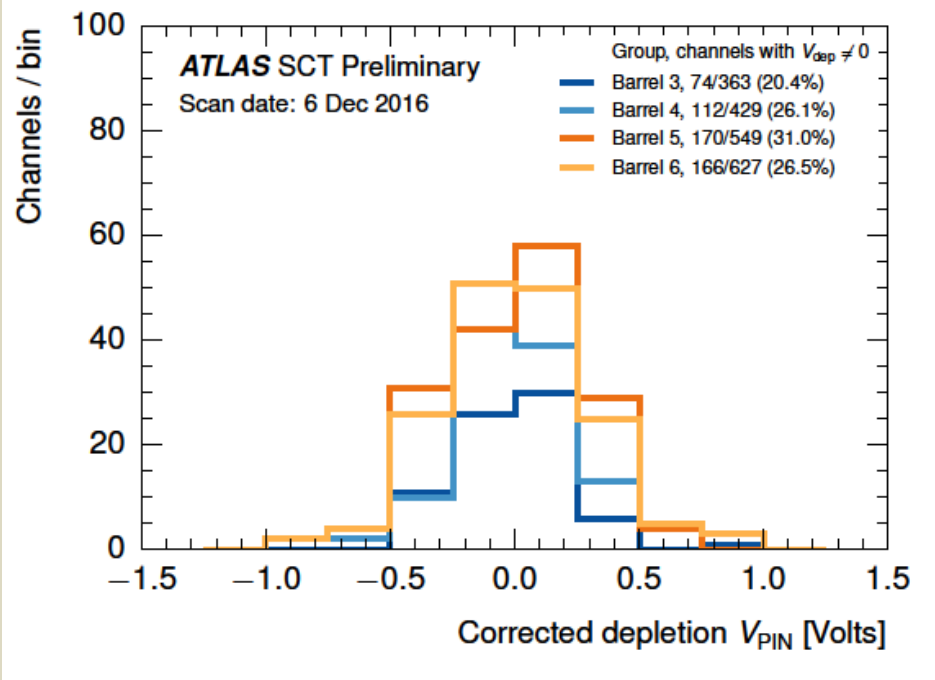






p-i-n diodes: Depletion Voltages

- Measure *p-i-n* diode currents.
- Scan bias voltage in 1V steps.
- Check if IV curve consistent with being horizontal
 - If not fit exponential curve → raw value for depletion voltage.
 - Correct for voltage drop along cables.
- Plot corrected depletion voltages



p-i-n diodes: Comparisons



- No significant change in depletion voltage as expected.
- Responsivity decreases
 - Asymptotic behaviour, similar to test beam but
 - In-situ: $R_{\infty} = 0.840 \pm 0.012$
 - Test beam: $R_{\infty} = 0.667 \pm 0.025$
- Don't understand decrease in responsivity for fully depleted *p-i-n* diodes.
- Don't understand discrepancy in-situ vs test beam.
 - Rate dependence/annealing effect?
- Decrease of responsivity ok for power budget.



Summary

- **In-situ radiation damage measured for VCSELs**
 - Slightly larger than expected from extrapolation of test beam data.
- **In-situ radiation damage measured for *p-i-n* diodes.**
 - Damage mechanism not understood
 - Asymptotic damage in-situ less than that measured in test beams.
- **Decrease in responsivity and light output up to the end of run 3 can be accommodated in links power budget for VCSELs and *p-i-n* diodes.**



Backup Slides

- Test beam papers
 - VCSELs: [NIM A 497 \(2003\) 294–304](#).
 - *p-i-n* diodes: [NIM A 456 \(2001\) 300-309](#)
- Stability plots for on-detector *p-i-n* diode currents, no beam operation in 2016 and 2017.

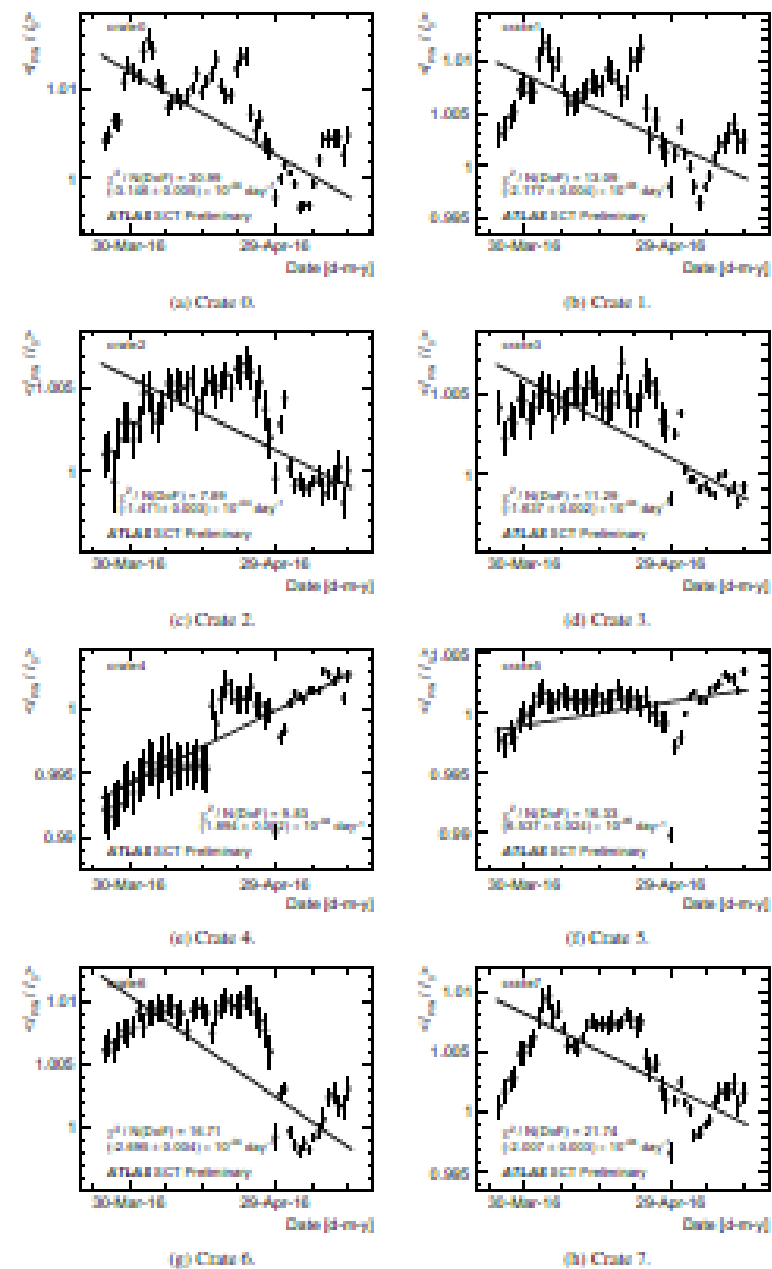


Figure 10: 2016. The (J_{DSD}/J_0) values of each RPD crate. Each point represents the mean value for one day averaged over all modules in a crate for the period before beam operation in 2016. The value of (J_{DSD}/J_0) is the normalized mean value of J_{DSD} (see text for details). The line shows results of the fits to the measurements. Note the highly suppressed zero on the vertical axis.

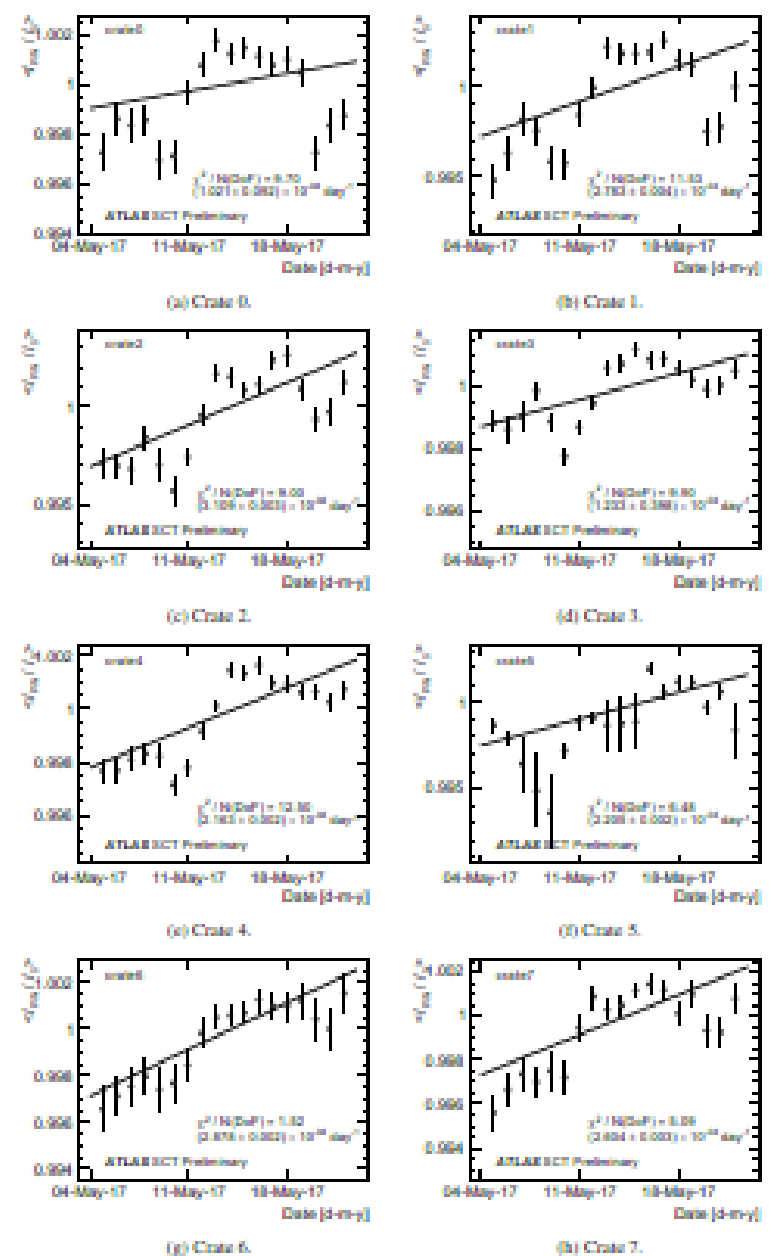


Figure 11: 2017. The (J_{DSD}/J_0) values of each RPD crate. Each point represents the mean value for one day averaged over all modules in a crate for the period before beam operation in 2017. The value of (J_{DSD}/J_0) is the normalized mean value of J_{DSD} (see text for details). The line shows results of the fits to the measurements. Note the highly suppressed zero on the vertical axis.